



DOCKET NO. 312971-P0023

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Jae Han CHA

ART UNIT: 2823

SERIAL NO.: 10/612,074

EXAMINER: Estrada, Michelle

FILING DATE: July 3, 2003

FOR: METHOD OF FORMING AN ISOLATION FILM IN A SEMICONDUCTOR  
DEVICE

**CHANGE OF ADDRESS**

September 23, 2004

ASSISTANT COMMISSIONER FOR PATENTS  
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ALEXANDRIA, VA 22313-1450  
SIR:

Please take note of the following change of address. All correspondence related to the  
above-captioned matter should now be directed to:

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Respectfully submitted,

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